



10-17-05

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/734,995
Confirmation No. 2050
Filing Date December 12, 2003
Inventor Nishant Sinha
Assignee Micron Technology, Inc.
Group Art Unit 2812
Examiner Jennifer M. Kennedy
Attorney's Docket No. MI22-2464
Customer No. 021567
Title Methods for Removal of Organic Materials (As Amended)

RESPONSE TO AUGUST 23, 2005 OFFICE ACTION

To: \ Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: Robert C. Hyta
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AMENDMENTS

Amendment to the Title

Please amend the title as follows:

~~Methods for Forming Capacitor Structures; and Methods for Removal of Organic~~
Materials